



61
AF/1762 IFW
Docket No.: 8733.565.00-US
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Yun-Ho Jung

Application No.: 10/025,907

Art Unit: 1762

Filed: December 26, 2001

Examiner: M. Padgett

For: APPARATUS AND METHOD OF
CRYSTALLIZING AMORPHOUS SILICON

Confirmation No.: 7489

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated April 12, 2004, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.